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APR 22 2005

Docket No. 740756-2659

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Application No. 10/678,139

Filed: October 6, 2003

For: METHOD FOR FABRICATING
SEMICONDUCTOR THIN FILM

)

) Group Art Unit: 2824

) Examiner: Michael Leventritt

) Confirmation No. 9428

) Date: April 22, 2005

CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

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Signature:

Name: Deborah Movahhedi

AMENDMENT

Mail Stop **AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 22, 2004, please amend the above identified application as follows.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.

W648126.1

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